

10/549859

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Attorney Docket :
33082 M 280

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yasuo Kobayashi, et al.

International Application No.: PCT/JP2004/004070

International Filing Date: March 24, 2004

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: PLASMA-ASSISTED DEPOSITION METHOD AND PLASMA-ASSISTED
DEPOSITION SYSTEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

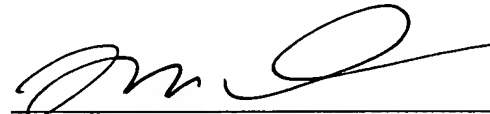
Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in the specification and the International Search Report (ISR) being filed herewith. Document AL on the attached PTO-1449 is cited both in Applicants' specification and the ISR. According to the ISR, documents AA, AB, and AC respectively are counterparts of documents AL, AO and AM. Copies of all cited foreign documents are enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
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In AFORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082M280	SERIAL NO. 107549859 To Be Assigned
	APPLICANT: Yasuo Kobayashi, et al.	
	FILING DATE Herewith	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA	6,544,901	4/8/03	Nakase			
	AB	6,652,709	11/25/03	Suzuki et al.			
	AC	2001/0054605	12/27/01	Suzuki et al.			
	AD						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
	AL	11-162960	6/18/99	Japan			Abstract	
	AM	2001-345312	12/14/01	Japan			Abstract	
	AN	2002-220668	8/9/02	Japan			Abstract	
	AO	2001-308071	11/2/01	Japan			Abstract	
	AP	2002-299330	10/11/02	Japan			Abstract	
	AQ							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR	
	AS	
EXAMINER:		DATE CONSIDERED:
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>		